

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

NISHIMOTO et al

Serial No.: 08/897,839

Filed: July 21, 1997

For: STRESS-ADJUSTED INSULATING  
FILM FORMING METHOD,  
SEMICONDUCTOR DEVICE AND  
METHOD OF MANUFACTURING THE  
SAME

Group Art Unit: 2814

Examiner: K. Eaton



PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136

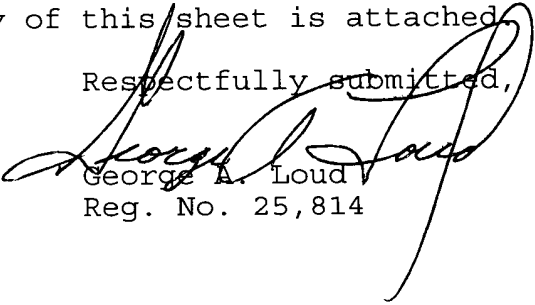
Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

It is respectfully requested that the time period for filing a Notice of Appeal in response to the office action of June 17, 1999, initially set to expire September 17, 1999, be extended two months up to and including November 17, 1999. The requisite \$380.00 fee for the requested extension is herewith attached.

Any additional fees may be charged to our Deposit Account No. 12-2174. A duplicate copy of this sheet is attached.

Respectfully submitted,

  
George A. Loud  
Reg. No. 25,814

Dated: November 17, 1999

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